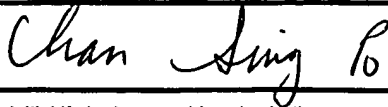


FORM PTO-1449 INFORMATION DISCLOSURE CITATION IN AN APPLICATION (Use several sheets if necessary)			Docket Number (Optional) YOR920000186US2		Application Number Not yet assigned		
			Applicant Kagan et al.				
			Filing Date Concurrently herewith		Group Art Unit Not yet assigned 1734		
U. S. PATENT DOCUMENTS							
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
SA	4,916,115	4/10/90	Mantese et al.	505	1		
SPC	4,952,556	8/28/90	Mantese et al.	505	1		
SPC	5,059,258	10-1991	Wefers et al.	148	272		
SPC	5,512,131	7/30/96	Kumar et al.	156	655.1		
SPC	5,620,850	4/15/97	Bamdad et al.	530	300		
SA	5,900,160	5/4/99	Whitesides et al.	216	41		
SPC	6,020,047	2/1/00	Everhart	428	209		
FOREIGN PATENT DOCUMENTS							
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
OTHER DOCUMENTS (including Author, Title, Date, Pertinent Pages, Etc.)							
SPC	<i>"Organic-Inorganic Heterostructure Electroluminescent Device Using a Layered Perovskite Semiconductor ($C_6H_5C_2H_4NH_3$)₂PbI₂</i> , Era et al., Appl. Phys Lett. 65 (6), 8 August 1994, pp. 676-678.						
SPC	<i>"Manipulation of the Wettability of Surfaces on the 0.1- to 1-Micrometer Scale Through Micromachining and Molecular Self-Assembly"</i> , by Abbott et al., Science, Vol. 257, 4 Sept. 1992, pp. 1380-1382.						
SPC	<i>"Maskless Photolithography: Embossed Photoresist as its own Optical Element"</i> , Paul et al., Applies Physics Letters, Vol. 73, No. 20, 16 November 1998, pp. 2893-2895.						
SPC	<i>"Patterning of Dielectric Oxide Thin Layers by Microcontact Printing of Self-Assembled Monolayers"</i> , Jeon et al., J. Mater. Res., Vol. 10, No. 12, December 1995, pp. 2996-2999.						
EXAMINER			DATE CONSIDERED				
			10/11/05				
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP §609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.							